

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Ogata et al.

Examiner:

Unassigned

Application No.: 10/589,382

Group Art Unit: Unassigned

Filed: August 15, 2006

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PHOTORESIST COMPOSITION AND

Dated: December 15, 2006

METHOD OF FORMING RESIST PATTERN

Confirmation No.: Unassigned

I hereby certify this correspondence is being deposited with the U.S. Postal Service as first class mail, postpaid in an envelope, addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Date: December 15, 2006

Name (Print)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this submission.

Remarks begin on page 3 of this submission.